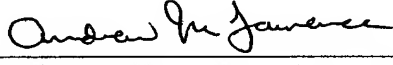




JFW

PATENT
Attorney Docket No. 29925/39028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:)
) I hereby certify that this paper is being
Jac-Chang Jung *et al.*) deposited with the United States Postal
) Service as first class mail, postage
Serial No. 10/619,254) prepaid, in an envelope addressed to:
) Mail Stop Amendment, Commissioner
Filed: July 14, 2003) for Patents, P.O. Box 1450, Alexandria,
) VA 22313-1450 on this date:
For: Organic Anti-Reflective Coating)
Composition And Method For) June 1, 2005
Forming Photoresist Patterns Using)
The Same)
Group Art Unit: 1756.)
) 
) Andrew M. Lawrence, Reg. No. 46,130
Examiner: Nicole M. Barreca) Attorney for Applicants

RESPONSE TO OFFICIAL ACTION DATED MAY 2, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

In response to the restriction requirement set forth in the official action dated May 2, 2005, the applicants hereby provisionally elect Group I, claims 1-11, for continued prosecution, with traverse.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

June 1, 2005


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